

Docket Number: 081468-0306865

Client Reference: P-0393.010-US

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

MARTIN LOWISCH et al.

Group Art Unit: 2812

Application No.: 10/716,939

Examiner:

Filed: November 20, 2003

Confirmation No.:

For: DEVICE MANUFACTURING METHOD AND COMPUTER PROGRAM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference(s) has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

The references were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully Submitted,

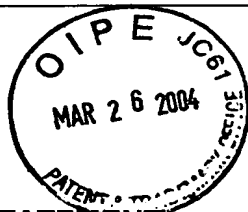
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	306865	P-0393.010-US

**INFORMATION DISCLOSURE STATEMENT
BY APPLICANT**

Applicant: LOWISCH et al.

Appln. No.: 10/716,939

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Examiner: Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	5,789,734	08/1998	TORIGOE et al.			
	BR	6,078,380	06/2000	TANIGUCHI et al.			
	CR	6,115,108	09/2000	CAPODIECI			
	DR						
	ER						
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	OR	1 251 402 A1	10/2002	EUROPE	BASELMANS et al.				
	PR								
	QR								
	RR								
	SR								
	TR								
	UR								
	VR								
	WR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	XR	Katsura OTAKI, "Asymmetric Properties of the Aerial Image in Extreme Ultraviolet Lithography," <i>Jpn. J. Appl. Phys.</i> 39:6819-6826 (2000)			
	YR				
	ZR				
	AAR				
	BBR				
	CCR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.